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JUL 20 2004

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In re Application of
Selvamanickam
Serial Number: 10/609,250
Filed: June 26, 2003
For: APPARATUS FOR AND METHOD OF
CONTINUOUS HTS TAPE BUFFER LAYER
DEPOSITION USING LARGE SCALE ION BEAM
ASSISTED DEPOSITION

PETITION UNDER
M.P.E.P. 708.02 IX

This is in response to the petition filed June 26, 2003, requesting that the above-identified application be granted Special Status under Section 708.02 IX of the MPEP and 37 CFR 1.102 (b) (**no fee required**).

The request for Special Status considered under Section 708.02 IX of the MPEP is granted because criteria under 37 CFR 1.102(b) has been met.

Accordingly the petition is **GRANTED**.

Marian C. Knode

Marian C. Knode, Special Programs Examiner
Technology Center 1700
Chemical and Materials Engineering

Serle Mosoff
KATTEN MUCHIN ZAVIS ROSENMAN
575 MADISON AVENUE
NEW YORK NY 10022-2585